

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Divisional Application of Application No. 10/144,025 of: )  
Riichiro TAKAHASHI et al. )  
Application No.: Unassigned ) Prior Application  
Filed: April 15, 2004 )  
For: ALKALINE SOLUTION AND ) Group Art Unit: 2851  
MANUFACTURING METHOD, AND ) Examiner: Alan A. MATHEWS  
ALKALINE SOLUTION APPLIED TO )  
PATTERN FORMING METHOD, RESIST )  
FILM REMOVING METHOD, SOLUTION )  
APPLICATION METHOD, SUBSTRATE )  
TREATMENT METHOD, SOLUTION )  
SUPPLY METHOD, AND )  
SEMICONDUCTOR DEVICE )  
MANUFACTURING METHOD )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PRELIMINARY AMENDMENT**

Prior to the examination of the above application, please amend this application as follows:

**Amendments to the specification** begin on page 2 of this paper; and

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 4 of this paper.

**Remarks** begin on page 6 of this paper.